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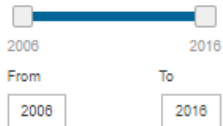
Content Type

- ☐ Conference Publications (14)
- ☐ Journals & Magazines (2)

Year

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Range



Author

Affiliation

Publication Title

Conference Location

- ☐ **Updating probabilistic method of the fuzzy control model's parameters of the production facilities**
Valery Finaev; Ekaterina Sinjavskaya; Arndt Lüder; Daria Ryashentseva
2016 IEEE 21st International Conference on Emerging Technologies and Factory Automation (ETFA)
Year: 2016
Pages: 1 - 7, DOI: 10.1109/ETFA.2016.7733535
IEEE Conference Publications
[Abstract](#) [\(html\)](#) (953 Kb)
- ☐ **User assistance by situational, task- and model-based process information filtering in interactive, semi-automated human-automation systems**
Marcel Langer; Dirk Söffker
2013 IEEE International Multi-Disciplinary Conference on Cognitive Methods in Situation Awareness and Decision Support (CogSIMA)
Year: 2013
Pages: 106 - 113, DOI: 10.1109/CogSIMA.2013.6523831
IEEE Conference Publications
[Abstract](#) [\(html\)](#) (1203 Kb)
- ☐ **Situation-based process guiding and supervision assistance system for semi-automated manufacturing processes**
Marcel Langer; Dirk Söffker
2012 IEEE International Conference on Systems, Man, and Cybernetics (SMC)
Year: 2012
Pages: 820 - 825, DOI: 10.1109/ICSMC.2012.6377829
IEEE Conference Publications
[Abstract](#) [\(html\)](#) (913 Kb)
- ☐ **Bake plate control using a robust multiplexed model predictive control (RMMPC)**
Endra Joelianto; Iqbal Ginanjar Prasetya
2011 2nd International Conference on Instrumentation Control and Automation
Year: 2011
Pages: 175 - 180, DOI: 10.1109/ICA.2011.6130151
IEEE Conference Publications
[Abstract](#) [\(html\)](#) (870 Kb)
- ☐ **Design of a high-precision fuzzy controller in tobacco first baking**
Che Guolin; Lai hua
Proceedings of 2011 IEEE International Conference on Service Operations, Logistics and Informatics
Year: 2011
Pages: 154 - 156, DOI: 10.1109/SOLI.2011.5986546
IEEE Conference Publications
[Abstract](#) [\(html\)](#) (203 Kb)
- ☐ **Embedded Microstructure Fabrication Using Developer-Permeability of Semi-Cross-Linked Negative Resist**
Yoshikazu Hirai; Koji Sugano; Toshiyuki Tsuchiya; Osamu Tabata
Journal of Microelectromechanical Systems